



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG801659211
Report verification at igi.org

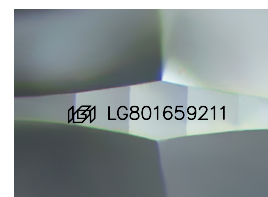
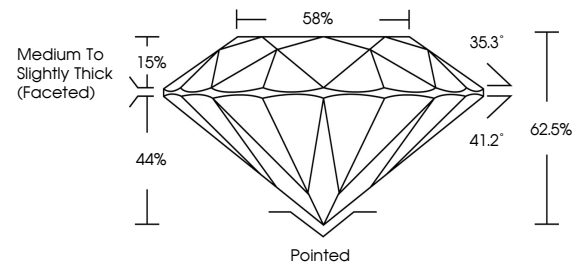
May 18, 2026	
IGI Report Number	LG801659211
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	6.48 - 6.51 X 4.06 MM
GRADING RESULTS	
Carat Weight	1.05 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG801659211

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

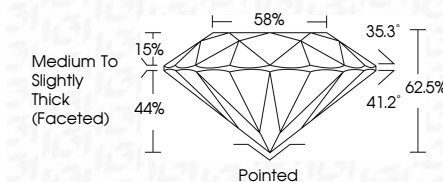
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

May 18, 2026	Carat Weight	1.06 CARAT
Report No: LG80169211	Color Grade	D
ROUND BRILLIANT	Clarity Grade	VVS 2
4.68 - 6.51 X 4.06 MM	Cut Grade	IDEAL
	Depth	62.5%
	Table	59%
	Grades	Medium To Slightly Thick (rounded)
	Cluef	Pointed
	Polsh	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Inscriptions(s)	691 LG80169211
	Comments:	The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
	Type Ila	